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CONFIRMATION NO. 9121

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|-----------------------------|---------------------------------------|--------------|------------------------|------------------------------------|
| SERIAL NUMBER<br>10/662,215 | FILING DATE<br>09/12/2003<br><br>RULE | CLASS<br>525 | GROUP ART UNIT<br>1765 | ATTORNEY<br>DOCKET NO.<br>85168PCW |
|-----------------------------|---------------------------------------|--------------|------------------------|------------------------------------|

## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This appln claims benefit of 60/409,992 09/12/2002

EC

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

None / EC

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 12/22/2003

|   |                              |  |                       |                            |
|---|------------------------------|--|-----------------------|----------------------------|
| Foreign Priority claimed<br><input type="checkbox"/> yes <input checked="" type="checkbox"/> no   | STATE OR<br>COUNTRY<br>NY    | SHEETS<br>DRAWING<br>3                   | TOTAL<br>CLAIMS<br>33 | INDEPENDENT<br>CLAIMS<br>3 |
| 35 USC 119 (a-d) conditions<br>met<br><input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after<br>Allowance | Verified and<br>Acknowledged | Examiner's Signature<br><i>Cris Chiu</i> | Initials<br>EC        |                            |

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## TITLE

Chemical mechanical planarization of wafers or films using fixed polishing pads and a nanoparticle composition

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|------------|---|---|
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